

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Cheung et al.

Serial No.: 09/604,347

Filed: July 5, 2000

Cont. of U.S. Serial No. 09/263,126

For: Apparatus For Electro Chemical  
Deposition of Copper Metallization  
With The Capability of In-Situ  
Thermal Annealing

Assistant Commissioner for Patents  
Washington, D.C. 20231

Group Art Unit: 1741

Examiner: Unknown  
Hicks

CERTIFICATE OF MAILING	
37 C.F.R. 1.8	
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Dear Sir:

INFORMATION DISCLOSURE STATEMENT

The applicants, and the attorney who signs below on the basis of the information supplied by the inventor and the information in his file, submit herewith patents, publications, or other information of which they are aware, which may be material to the examination of this application and in respect of which there may be a duty to disclose in accordance with 37 C.F.R. § 1.56.

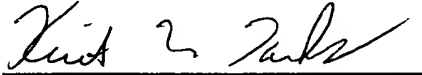
While the information submitted in this Information Disclosure Statement may be material pursuant to 37 C.F.R. § 1.56, it is not intended to constitute an admission that any patent, publication, or other information referred to therein is prior art for this invention unless specifically designated as such.

In accordance with 37 C.F.R. § 1.97, this Information Disclosure Statement is not to be construed as a representation that a search has been made or that no other possibly material information as defined in 37 C.F.R. § 1.56(a) exists.

The patents and/or publications submitted herewith are set forth on the attached Form PTO-1449.

If the sum of \$240.00 is due under 37 C.F.R. § 1.17(p) pursuant to § 1.97(c), the Commissioner is hereby authorized to charge this fee, and any other fee necessary to make this submission timely, to the Deposit Account No. 20-0782/AMAT/3421.C1/KMT of Thomason, Moser & Patterson, L.L.P. for the necessary amount.

Respectfully submitted,



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